

COURSE: MICROSYSTEMS AND NANOELECTRONICS						
MASTER: ELECTRONIC SYSTEMS ENGINEERING AND APPLICATIONS	YEAR: 2014-15	TERM: 2nd				

	WEEKLY PLANNING								
WEEK	SESSION	DESCRIPTION	GROUPS (mark X)		Special room for session (computer classroom,	WEEKLY PROGRAMMING FOR STUDENT			
			LECTURES	SEMINARS/ LAB ¹	audio-visual classroom)	DESCRIPTION	CLASS HOURS	HOMEWORK HOURS (Max. 7h week)	
1	1	Introduction to Electronic Microsystems and MEMS. Historical overview and Applications. Design, Microfabrication, Integration and Packaging of MEMS and Microsystems	x			Previous reading. Answering questions about background.	1,5	4	
1	2	Examples of Microsystems and MEMS: Pressure and Gas Sensors, Accelerometers, Gyroscopes and microfluidics Systems	x			Previous reading. Revision of Class Materials.	1,5		
2	3	MOEMS: Micro-optical Devices: micromirrors and MEMS for optical Communication and Sensing	x			Previous reading. Revision of Class Materials.	1,5	7	
2	4	Liquid Crystals, microscreens and displays	х			Previous reading. Revision of Class Materials.	1,5	/	
3	5	Microsystems: Discussion of Case Studies		х		The students, split in groups, will prepare the description of one microsystem that will be discussed in class	1,5		

Total 1 (Hours of class plus student homework hours between weeks 1-7)							
	¹ A maximum of 1-2 lab sessions						
7	14	Nanoelectronics: Discussion of Case Studies		XThe students, split in groups, will prepareXthe description of one nanoelectronicsystem that will be discussed in class		1,5	5
7	13	Nanoelectronic Sensors and Sensors arrays	x		Previous reading. Revision of Class Materials.	1,5	
6	12	Nanoelectronic Component and Systems for Data Transmission and Interfaces	x		Previous reading. Revision of Class Materials.	1,5	
6	11	Nanoelectronic Logic Devices	x		Previous reading. Revision of Class Materials.	1,5	
5	10	Quantum Computing	x		Previous reading. Revision of Class Materials.	1,5	
5	9	Molecular Electronics and Metatronics	x		Previous reading. Revision of Class Materials.	1,5	
4	8	Technological Aspects: New materials and Components (CNT, Graphene,)	x		Previous reading. Revision of Class Materials.	1,5	
4	7	Technological Aspects: Fabrication	x		Previous reading. Revision of Class Materials.	1,5	
3	6	Fundamentals for Nanoelectronics	x		Previous reading. Revision of Class Materials.	1,5	

1-7		Tutorials, handing in, etc					10	
8		Assessment					3	7
Subtotal 2					3	17		
Total 2 (Hours of class plus student homework hours at week 8)				20				

TOTAL (Total 1 + Total 2)

75